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Serial No.:	09/781,616	Conf. No.:	9505	JAN 18 2005
Filing Date:	02/12/2001	Art Unit:	2141	
Applicant:	Iwao Hatanaka	Examiner:	Lien, Tan	
Title:	METHOD AND SYSTEM FOR AUTOMATED SESSION RESOURCE CLEAN-UP IN A DISTRIBUTED CLIENT-SERVER ENVIRONMENT		Docket No.:	CHA9-99-015 (IMBC-0105)

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 703-872-9306

Transmitted herewith is: **After-Final Amendment in 9 pages**

in the above identified application.

- No additional fee is required.
- The Commissioner is hereby authorized to charge and credit Deposit Account No. 09-0469 (IBM) as described below.
 - Credit any overpayment.
 - Charge any additional fee required.

DATE: January 18, 2005

Michael F. Hoffman, Reg. No. 40,019

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below.

Darcie L. DeLisle
(Person transmitting this correspondence)

January 18, 2005

Date

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